

SEMICON JAPAN 2019

We are pleased to announce that we participate SEMICON JAPAN 2019 to introduce our latest products and technologies. We are looking forward to seeing you at our booth.

Date: 11 – 13 December 2019 10:00- 17:00

Venue/ Booth: Tokyo Big Sight, West Hall First Floor, **2443**

Main Exhibit



High Accuracy Electric Pneumatic Regulator

APU series

- High accuracy regulator of fine pressure and flow control
- A wide lineup from small to large flow rates
- Reproducibility $\pm 0.1\%$

Applications: Dispenser, wafer polishing, wafer probing, etc.

** Sample exhibits of the latest models under development will be available



Bombing / Gross / Fine Leak Test System

MSX-7000

- Fully automatic inspection system that carries out bombing, gross and fine leak testing
- DUT sizes: **1.0×0.8 (Industry's smallest)**, 1.2×1.0mm

Applications: Recommended for the testing of crystal oscillators and MEMS

** Demonstrated by video



Ultra-Fine Leak Test System

MUH-0100

- Dedicated ultra fine leak testing system using helium gas
- Minimum detectable leak rate $< 4 \times 10^{-15} \text{ Pa} \cdot \text{m}^3/\text{s}$
- Maximum DUT size $\phi 44 \times \text{L}31 \text{ mm}$ (30 x 30)

Applications: Recommended for testing small electronic components, MEMS, and other optical devices